INTERNATIONAL SEARCH REPORT

Int nal Application No PCT/IB2004/003617

A. CLASSIFICATION OF SUBJECT MATTER IPC 7 H03H3/007						
According to International Patent Classification (IPC) or to both national classification and IPC						
B, FIELDS SEARCHED						
Minimum documentation searched (classification system followed by classification symbols) IPC 7 H03H						
Documentation searched other than minimum documentation to the extent that such documents are included. In the fields searched						
Electronic data base consulted during the international search (name of data base and, where practical, search terms used) EPO-Internal, WPI Data, PAJ						
C. DOCUME	NTS CONSIDERED TO BE RELEVANT					
Category °	Citation of document, with indication, where appropriate, of the	relevant passages	Relevant to claim No.			
X	DE 198 52 878 A1 (SIEMENS AG) 18 May 2000 (2000-05-18) figures 5,6 column 4, lines 12,13,15,16,22,23,25,31-37,59-6 column 3, lines 61,62	3/	1-4,6-12			
X Furt	her documents are listed in the continuation of box C.	Patent family members are listed	in annex.			
*A' document defining the general state of the art which is not considered to be of particular relevance *E' earlier document but published on or after the international filling date *L' document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified) *O' document referring to an oral disclosure, use, exhibition or other means *P' document published prior to the international filing date but later than the priority date claimed *A' document or priority date and not in con cited to understand the prioritin content on the cannot be considered novel involve an inventive step when the priority date and not in con cited to understand the prioritin cannot be cannot be cannot be considered novel involve an inventive step when the priority date and not in con cited to understand the prioritin city and the prioritin lavention *X' document of particular relevant cannot be considered novel involve an inventive step when the cannot be considered to involve an inventive step when the cannot be considered novel involve an inventive step when the cannot be considered to involve an inventive step when the cannot be considered novel involve an inventive step when the cannot be considered novel involve an inventive step when the cannot be considered novel involve an inventive step when the cannot be considered novel involve an inventive step when the cannot be considered novel involve an inventive step when the cannot be considered novel involve an inventive step when the cannot be considered novel involve an inventive step when the cannot be considered novel involve an inventive step when the cannot be considered novel involve an inventive step when the cannot be considered novel involve an inventive step when the cannot be considered novel involve an inventive step when the cannot be considered novel involve an inventive step when the cannot be considered novel involve an inventive step when the cannot be considered novel i		 "X" document of particular relevance; the cannot be considered novel or cannot involve an inventive step when the document of particular relevance; the cannot be considered to involve an involve and the comment is combined with one or not ments, such combination being obvi 	ct with the application but e or theory underlying the e; the claimed invention cannot be considered to the document is taken alone e; the claimed invention e an inventive step when the e or more other such docugo obvious to a person skilled patent family			
1	.0 February 2005	17/02/2005				
Name and mailing address of the ISA European Patent Office, P.B. 5818 Patentlaan 2 NL – 2280 HV Rijswijk Tel. (+31-70) 340-2040, Tx. 31 651 epo nl, Fax: (+31-70) 340-3016		Authorized officer Plathner, B-D				

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In 1al Application No PCT/IB2004/003617

C.(Continu	ation) DOCUMENTS CONSIDERED TO BE RELEVANT	
Category °		Relevant to claim No.
A	POURKAMALI S ET AL: "SOI-based HF and VHF single-crystal silicon resonators with sub-100 nanometer vertical capacitive gaps" TRANSDUCERS, SOLID-STATE SENSORS, ACTUATORS AND MICROSYSTEMS, 12TH INTERNATIONAL CONFERENCE, IEEE, vol. 1, 9 June 2003 (2003-06-09), pages 837-840, XP010646838 figure 1 page 837, left-hand column, lines 5,6 page 837, right-hand column, lines 9-13 page 838, left-hand column, line 7 - page 838, right-hand column, line 19	1-12
A	SHAW K A ET AL: "Integrating SCREAM micromachined devices with integrated circuits" MICRO ELECTRO MECHANICAL SYSTEMS, 1996, MEMS '96, PROCEEDINGS. AN INVESTIGATION OF MICRO STRUCTURES, SENSORS, ACTUATORS, MACHINES AND SYSTEMS. IEEE, THE NINTH ANNUAL INTERNATIONAL WORKSHOP ON SAN DIEGO, CA, USA 11-15 FEB. 1996, NEW YORK, NY, USA, IEEE, 11 February 1996 (1996-02-11), pages 44-48, XP010159358 ISBN: 0-7803-2985-6	1-12
A	KELLER C G ET AL: "Nickel-filled Hexsil Thermally Actuated Tweezers" SOLID-STATE SENSORS AND ACTUATORS, 1995 AND EUROSENSORS IX., vol. 2, 25 June 1995 (1995-06-25), pages 376-379, XP010305145 abstract; figure 4	1-12

INTERNATIONAL SEARCH REPORT

Int : 1al Application No PCT/1B2004/003617

Patent document cited in search report	Publication date	Patent family member(s)	Publication date
DE 19852878 A1	18-05-2000	NONE	